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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

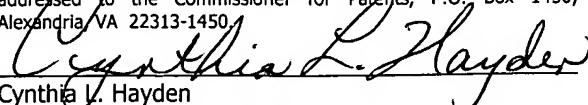
Randy Skocypec et al.	§	Art Unit:	1746
Serial No.: 10/622,307	§	Examiner:	Bibi Sharidan Carrillo
Filed: July 18, 2003	§	Docket:	ITL.1017US P16704
For: Cleaning Semiconductor Wafers	§	Assignee:	Intel Corporation
	§		

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY TO OFFICE ACTION

Sir:

In response to the office action mailed August 24, 2006, please amend the above-referenced patent application as follows:

Date of Deposit: <u>October 25, 2006</u>
I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Cynthia L. Hayden